

09/247,622

	Type	L #	Hits	Search Text	DBs
1	BRS	L1	2998	kerr near2 effect\$5	USPAT; EPO; JPO
2	BRS	L5	4106	magnet\$5 adj2 optic	USPAT; EPO; JPO
3	BRS	L9	628	1 and 5	USPAT; EPO; JPO
4	BRS	L13	32269	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 (phase near5 differen\$5)	USPAT; EPO; JPO
5	BRS	L17	3448	reflect\$5 same ((s and p) near2 (polariz\$5 or component\$3))	USPAT; EPO; JPO
6	BRS	L21	227465	(magnetic near2 (disk or disc)) or wafer	USPAT; EPO; JPO
7	BRS	L25	109170	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 (thickness)	USPAT; EPO; JPO
8	BRS	L29	35	9 and 13	USPAT; EPO; JPO
9	BRS	L33	18	29 and 17	USPAT; EPO; JPO
10	BRS	L37	552	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 (kerr near2 effect\$5)	USPAT; EPO; JPO
11	BRS	L41	11	37 and 13 and 17	USPAT; EPO; JPO
12	BRS	L45	6	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 (kerr near2 effect\$5)) with (phase near5 differen\$5)	USPAT; EPO; JPO
13	BRS	L49	280	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 thickness) with (phase near5 differen\$5)	USPAT; EPO; JPO
14	BRS	L53	809	((determin\$5 or detect\$5 or calculat\$5 or measur\$5) near8 magnetic) with (phase near5 differen\$5)	USPAT; EPO; JPO
15	BRS	L57	2	49 and 5 and 17	USPAT; EPO; JPO
16	BRS	L61	21	49 and 17	USPAT; EPO; JPO
17	BRS	L65	19	61 and 13	USPAT; EPO; JPO

	Type	L #	Hits	Search Text	DBs
18	BRS	L69	2	61 not 65	USPAT; EPO; JPO
19	BRS	L73	236	((determin\$5 or detect\$5 or measur\$5) and mark\$5) near8 (defect)	USPAT; EPO; JPO
20	BRS	L77	6553	scribe	USPAT; EPO; JPO
21	BRS	L89	3	73 and 77	USPAT; EPO; JPO
22	BRS	L93	107	13 and 17 and 21	USPAT; EPO; JPO
23	BRS	L97	4568	projection near2 exposure	USPAT; EPO; JPO
24	BRS	L101	76	93 not 97	USPAT; EPO; JPO